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Application Number		09449021		
Filing Date		1999-11-24		
First Named Inventor	Emmelmann			
Art Unit		2192		
Examiner Name	Chuck Kendall			
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/C.K./	7	Sun Microsystems, JavaBeans™ technology home page, (See http://java.sun.com/beans)					
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/C.K./	9	H.E.I. Informationssysteme GmbH, heitml web site version November 11, 1998 (http://web.archive.org/web/19981111190703/http://www.heitml.com/)					

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